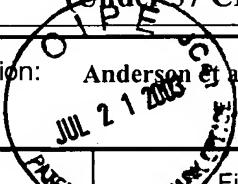


TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
BUR920030031US1In Re Application: **Anderson et al.**

Serial No.

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Examiner

Group Art Unit

METHOD OF FORMING FREESTANDING SEMICONDUCTOR LAYER**Payment of Fee**

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